

WR:gte 04/08/04
PATENT

Express Mail Label No. EV331580294US
Date of Deposit: April 8, 2004
Attorney Reference Number 6047-68313

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Farnworth et al.

Application No. Not yet assigned

Filed: Herewith

Confirmation No. Not yet assigned

For: NANOTUBE SEMICONDUCTOR
DEVICES AND METHODS FOR MAKING
THE SAME

Examiner: Not yet assigned

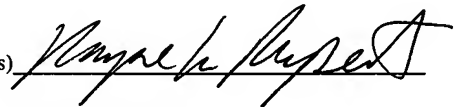
Art Unit: Not yet assigned

Attorney Reference No. 6047-68313

CERTIFICATE OF EXPRESS MAILING

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Attorney
for Applicant(s)



Date Mailed April 8, 2004

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INFORMATION DISCLOSURE STATEMENT
FOR CONTINUING APPLICATIONS

Listed on the accompanying form PTO-1449 are several English-language documents. Applicants respectfully request that such documents be listed as references cited on the issued patent.

The present application relies upon U.S. Patent Application No. 10/315,511, which was filed December 9, 2002, for an earlier filing date under 35 U.S.C. § 120. Furthermore, documents listed on the accompanying form PTO-1449 were disclosed to or cited by the Patent Office in the earlier U.S. application.

Copies of the documents listed on the accompanying form PTO-1449 that were cited by applicants in the earlier application need not be sent to the Patent Office pursuant to 37 C.F.R. § 1.98. However, applicants will furnish the Patent Office with such copies upon request.

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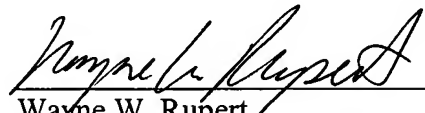
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The filing of this Information Disclosure Statement shall not be construed to be an admission that the information cited in the statement is, or is considered to be, prior art or otherwise material to patentability as defined in 37 C.F.R. §1.56.

Respectfully submitted,

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	First Named Inventor	Farnworth
	Art Unit	Not yet assigned
	Examiner Name	Not yet assigned

U.S. PATENT DOCUMENTS

NOTE: If this application was filed after June 30, 2003, copies of United States patents and United States published patent applications do not have to be provided to the Patent Office. This requirement of 37 C.F.R. § 1.98(a)(2)(i) has been waived by the United States Patent and Trademark Office pursuant to the Official Gazette Notice on August 5, 2003 (1276 OG 55).

Examiner's Initials*	Cite No. (optional)	Number	Publication Date	Name of Applicant or Patentee
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<p>* Examiner: Initial if reference considered, whether or not in conformance with MPEP 609. Draw line through cite if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>	

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